

SHORT COURSE REGISTRATION FORM, Spring 2002

American Vacuum Society/New Mexico Chapter

Send Registration Forms and checks payable to AVS/NMC to:

Heidi Ruffner
Sandia National Laboratories
P. O. Box 5800, M/S 0958
Albuquerque, NM 87185-0958
Phone/FAX (505) 286-1308

Name _____

Company _____ E-mail _____

Address _____

City _____ State _____ Zip _____

Telephone # _____ FAX # _____

Job Position _____ Years in Technology _____

Student Scholarship Applicant? Yes ☐ No ☐

<i>Fees</i>	<i>Courses</i>	<i>Dates</i>
_____ \$1,295	A Basic Vacuum Technology	Mon.-Fri., May 13-17
_____ \$875	B Operation and Maintenance of Vacuum Pumping Systems	Mon. & Tues., May 13 & 14
_____ \$625	C Vacuum System Design	Mon., May 13
_____ \$625	D An Introduction to Ellipsometry	Tues. May 14
_____ \$525	E Vacuum Leak Detection	Wed. May 15
_____ \$625	F Cryopump Technology	Wed. May 15
_____ \$525	G Plasma Etching and Reactive Ion Etching G1 – Fundamentals	Thurs. May 16
_____ \$775	G2 - Fundamentals and Applications	Thurs. & Fri., May 16 & 17
_____ \$525	H Microfabrication Technology for Micro-electromechanical Systems	Thurs. May 16
_____ \$525	I Partial Pressure Analyzers: Analysis & Applications	Fri. May 17
_____ \$525	J Focused Ion Beams: Principles & Applications	Fri. May 17

\$ _____ TOTAL AMOUNT DUE

Payment by: ☐ Check ☐ Visa ☐ Master Card

Credit Card # _____ Expiration date: _____

Signature authorizing use of credit card _____

All classes meet from 8:30 AM – 4:30 PM at the Wyndham Hotel, 2910 Yale Blvd., SE, Albuquerque, New Mexico
Thank you!